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Dated: April 25, 2005

Signature: 

(Michael R. Hull)

Docket No.: 29936/39474
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Cha Deok Dong et al.

Application No.: 10/617,476

Confirmation No.: 3456

Filed: July 11, 2003

Art Unit: 2829

For: METHOD OF MANUFACTURING A
SEMICONDUCTOR DEVICE

Examiner: C. P. Chaudhari

AMENDMENT AFTER FINAL ACTION (37 C.F.R. SECTION 1.116)

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated March 2, 2005, finally rejecting claims 1-11, and allowing claims 12-16, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.